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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sreenivasan, Sidlgata V.  
App. No.: 10/614,716 GPAU: 1722  
Filing Date: July 7, 2003 Examiner: Thukhanh T. Nguyen  
Dkt. No.: P90-32V30 Conf. No.: 7603  
For: Conforming Template for Patterning Liquids Disposed on Substrates

INFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT  
Commissioner for Patents  
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Alexandria, VA 22313-1450

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The following information is submitted in compliance with Applicants' duty of disclosure and pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98. The undersigned brings the patents, publications, applications or other information identified in the attached **Form(s) PTO/SB/08A** to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed during the period specified in § 1.97(c). Accordingly, the fee set forth in §1.17(p) is required and provided as shown below.

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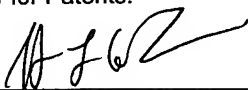
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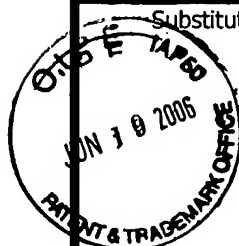
  
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Respectfully Submitted,



Michael D. Carter  
Reg. No. 56,661  
Registered Patent Agent  
Legal Department  
Molecular Imprints, Inc.  
P.O. Box 81536  
Austin, TX 78758-1536  
(512) 339-7760  
(512) 491-8918 (fax)

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*(use as many sheets as necessary)*

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|-------|---|----|---|
| Sheet | 1 | of | 4 |
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|                        |                   |
|------------------------|-------------------|
| APPLICATION NUMBER     | 10/614,716        |
| FILING DATE            | 07 July 2003      |
| FIRST NAMED INVENTOR   | Sreenivasan et al |
| GROUP ART UNIT         | 1722              |
| EXAMINER NAME          | Emmanuel S. Luk   |
| ATTORNEY DOCKET NUMBER | P90-32V30         |

## U.S. PATENT DOCUMENTS

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|   |           |    |   | EXAMINER NAME            | Emmanuel S. Luk   |
| ATTORNEY DOCKET NUMBER  | P90-32V30 |    |   |                          |                   |
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|--|-----|---|--|
|  | G7  | Translation of Japanese Patent 61-40845, 2/1/1986   |  |
|  | G8  | Translation of Japanese Patent 02-248480, 10/1/1990   |  |
|  | G9  | Translation of Japanese Patent 03-090345, 4/1/1991  |  |
|  | G10 | Translation of Japanese Patent 09-278490, 10/1/1997   |  |
|  | G11 | Abstract of Japanese Patent 03-090345, 4/1/1991   |  |
|  | G12 | Abstract of Japanese Patent 09-278490, 10/1/1997  |  |
|  | G13 | BIEN ET AL., Characterization of Masking Materials for Deep Glass Micromachining, J. Micromech. Microeng. 13 pp. S34-S40 1/1/2003   |  |
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|  | G18 | KOBAYASHI ET AL., Batch Bulk-Mircomachined High-Precision Metal-On-Insulator Microspires and Their Application to Scanning Tunneling Microscopy, J. Micromech. Microeng. 14; pp. S76-S81 1/1/2004 |  |
|  | G19 | KONIJN ET AL., Nanoimprint Lithography of Sub-100nm 3D Structures, Microelectronic Engineering 78-79; pp653-658 1/1/2005  |  |
|  | G20 | KUNNAVAKKAM ET AL., Low-cost, Low-loss Microlens Arrays Fabricated by Soft-Lithography Replication Process, Applied Physics Letters, Volume 82, Number 8 2/24/2003                                |  |
|  | G21 | MANSELL ET AL., Binary-Optic Smoothing with Isotropic Etching, Applied Optics; Vol. 36, No. 20 7/10/1997  |  |
|  | G22 | WAHEED ET AL., Balancing Aerial Image Intensity for Alternating Aperture Phase Shift Masks Using an Isotropic Dry-Etch, Proceedings of SPIE Vol. 5130 4/18/2003                                   |  |
|  | G23 | SANO ET AL., Submicron Spaced Lens Array Process Technology for a High Photosensitivity CCD Image Sensor, IEEE IEDM Dig.; pp. 283-286 1/1/1990  |  |
|  | G24 | TSUKAMOTO ET AL., High Sensitivity Pixel Technology for a 1/4 inch PAL 430k pixel IT-CCD, IEE Custom Integrated Circuits Conference 1/1/1996  |  |

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|  | G25 | YONEDA ET AL., Translation of Japanese Patent 02-248480, Transparent Substrate with Water-Repellent and Antistaining Properties, and Structure Equipped Therewith 10/4/1990          |  |
|  | G26 | YONEDA ET AL., Translation of Japanese Patent 02-248480, Transparent Substrate Material with Water-Repellent and Anti-Staining Properties and Structure Equipped with Same 10/4/1990 |  |
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